

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
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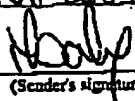
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Art Unit: 3723

Title: POLISHING PAD FOR
ELECTROCHEMICAL-MECHANICAL
POLISHING

<p align="center"><u>Certificate of Facsimile Transmission</u></p> <p>I, Marijose Monsolve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted to the USPTO's Centralized Facsimile Number for Official Patent Application Related Correspondence, facsimile No. (703) 872-9306 on <u>04 AUG 2004</u></p> <p align="center"> (Sender's signature)</p>
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA, 22313-1450

RESPONSE AND ELECTION

In response to the Office Action of July 28, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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